

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Seong-jin MOON et al.

Serial No. 10/756,421

Group Art Unit: 2621

Confirmation No. 2968

Filed: January 14, 2004

Examiner: Christopher O. Onuaku

For: RECORDING MEDIUM FOR STORING VIRTUALLY DELETED STILL PICTURE  
INFORMATION

**COMMENTS REGARDING STATEMENT OF REASONS FOR ALLOWANCE**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

A Statement of Reasons for Allowance was forwarded in the Notice of Allowability mailed on July 2, 2007.

MPEP §1302.14 states, in part:

Where specific reasons are recorded by the examiner, care must be taken to ensure that statements of reasons for allowance (or indication of allowable subject matter) are accurate, precise and do not place unwarranted interpretations, whether broad or narrow upon the claims. The examiner should keep in mind the possible misinterpretations of his or her statement that may be made and its possible estoppel effects.

The Examiner characterizes certain features of various claims. However, the Examiner has not recited the appropriate language for the appropriate claims as pending and allowed in the application.

By way of example, a passage from the Field of Invention section of the Specification is included in the Statement of Reasons for Allowance. It is respectfully submitted that the

passage should not be a basis for any estoppel or interpretation.

The foregoing is merely meant to be exemplary, and does not point out all of the discrepancies between the Examiner's Statement of Reasons for Allowance and the claimed features of the allowed claims.

It is further submitted that the claims speak for themselves and should not be interpreted based on the Examiner's characterizations of same. It is also submitted that the claims provide their own best evidence as to the reasons for allowance.

In summary, it is submitted that the Examiner's Statement "raises possible misinterpretations... and possible estoppel effects" (M.P.E.P. §1302.14) and is therefore improper.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: 10/2/2007

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